

Attorney Docket No. 071469-0306881
Client Reference: ES-016

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Vaidyanathan BALASUBRAMANIAM, Koichiro INAZAWA

Application No.: Confirmation No:
Filed: December 23, 2003 Group No.:
For: METHOD AND APPARATUS FOR REMOVING PHOTORESIST FROM A SUBSTRATE Examiner

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: Vaidyanathan BALASUBRAMANIAM
Citizenship: INDIA
Residence: Beverly, MA 01915

Second applicant: Koichiro INAZAWA
Citizenship: JAPAN
Residence: Peabody, MA 01960

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD AND APPARATUS FOR REMOVING PHOTORESIST FROM A SUBSTRATE

Docket number assigned to this application: 071469-0306881

Suggested Classification: Class:
Subclass:
Technology Center to which subject matter is assigned:

Total number of drawing sheets: 8

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

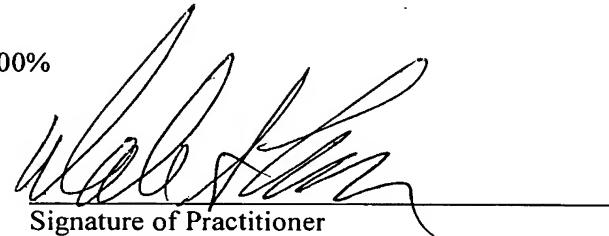
The assignee(s) of this application is/are:

Tokyo Electron Limited
3-6, Akasaki 5-chome, Minato-ku
Tokyo, 107
JAPAN

Extent of interest of assignee in application: 100%

Date: December 23, 2003

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Signature of Practitioner

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